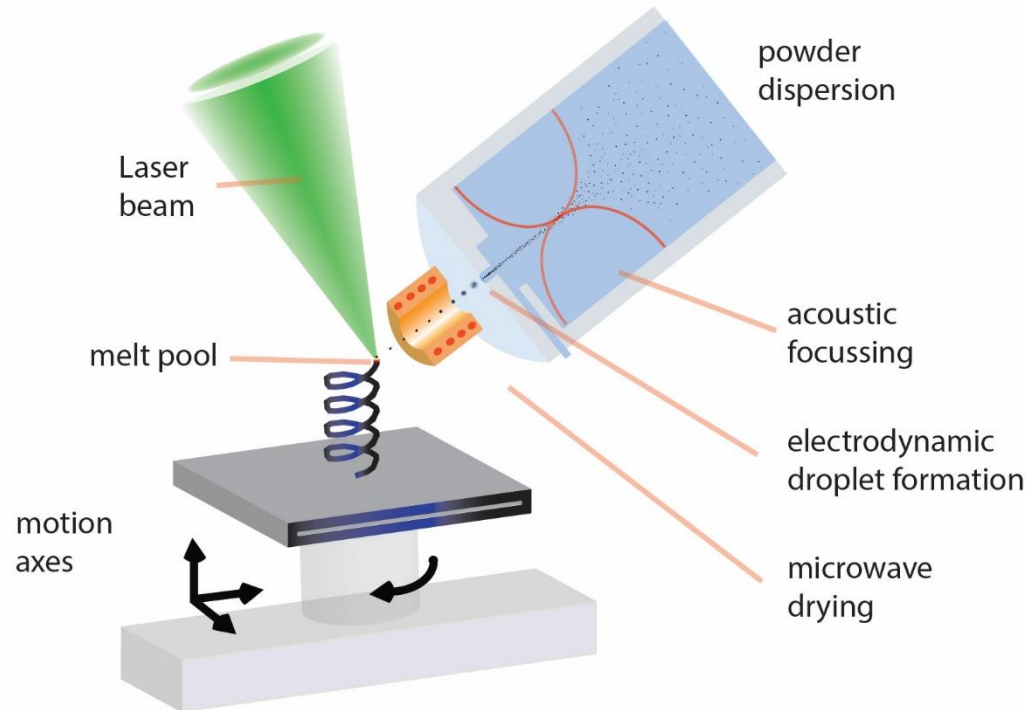


Powder focusing for beam induced laser 3D printing



Teams complete - project on track

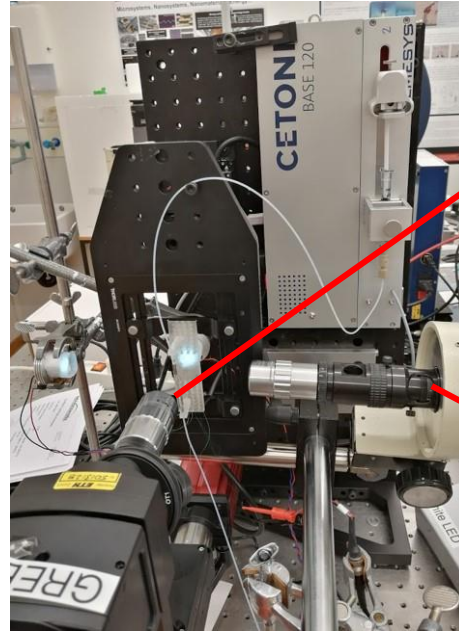
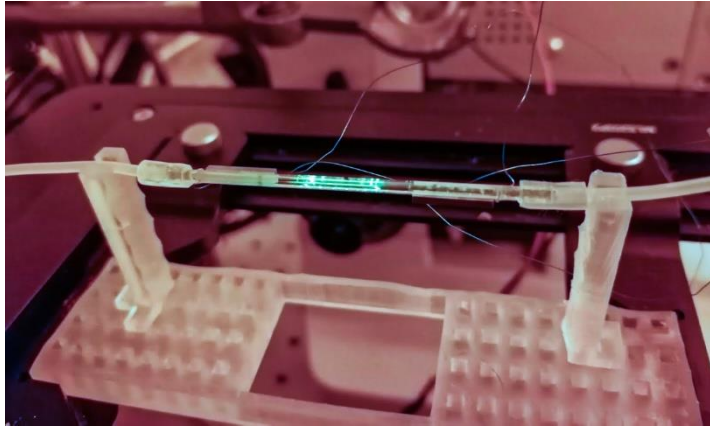
Copper + Silicon as powders selected

Sub-systems ready

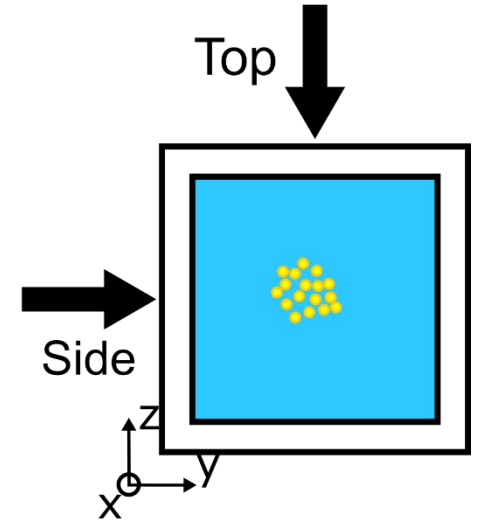
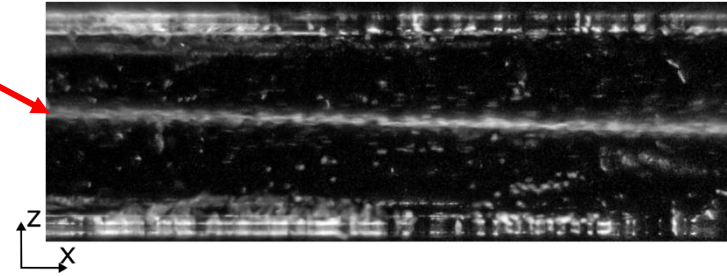
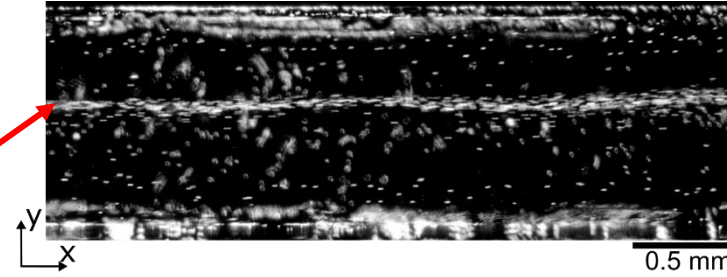
- Powder focusing
ETHZ IMES J. Dual, **PhD Michael Gerlt**
- Electrohydrodynamic droplet formation
ETHZ LTNT D. Poulikakos, **PD Patrik Rohner**
- Powder drying on flight
PSI M. Pouchon, **PhD Kwanghoon Choi**
Empa S. Vaucher
- Simulation of liquid – particle drying process
EPFL LFMI F. Gallaire, **PhD Shahab Eghbali**
- Integration into focused laser 3-D printing system
Empa LAMP P. Hoffmann, **PD B. Lanfant**
Dr. S. Vaucher, Dr. M. Leparoux

Acoustic powder focusing

Experimental Setup

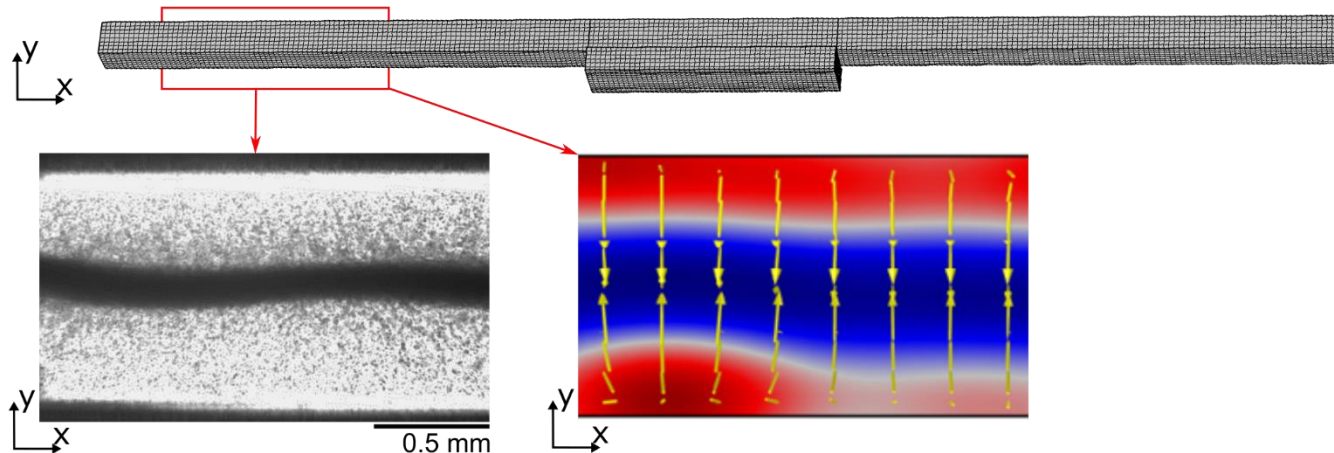


PS Particle - $d = 5 \mu\text{m}$

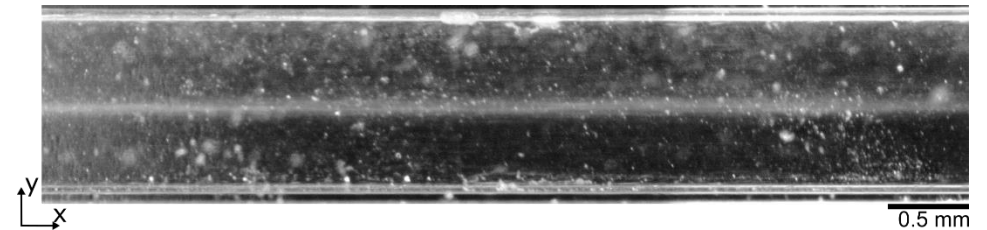


Top: $57 \mu\text{m} \pm 28 \mu\text{m}$, Side: $89 \mu\text{m} \pm 25 \mu\text{m}$.

3D Numerical Model



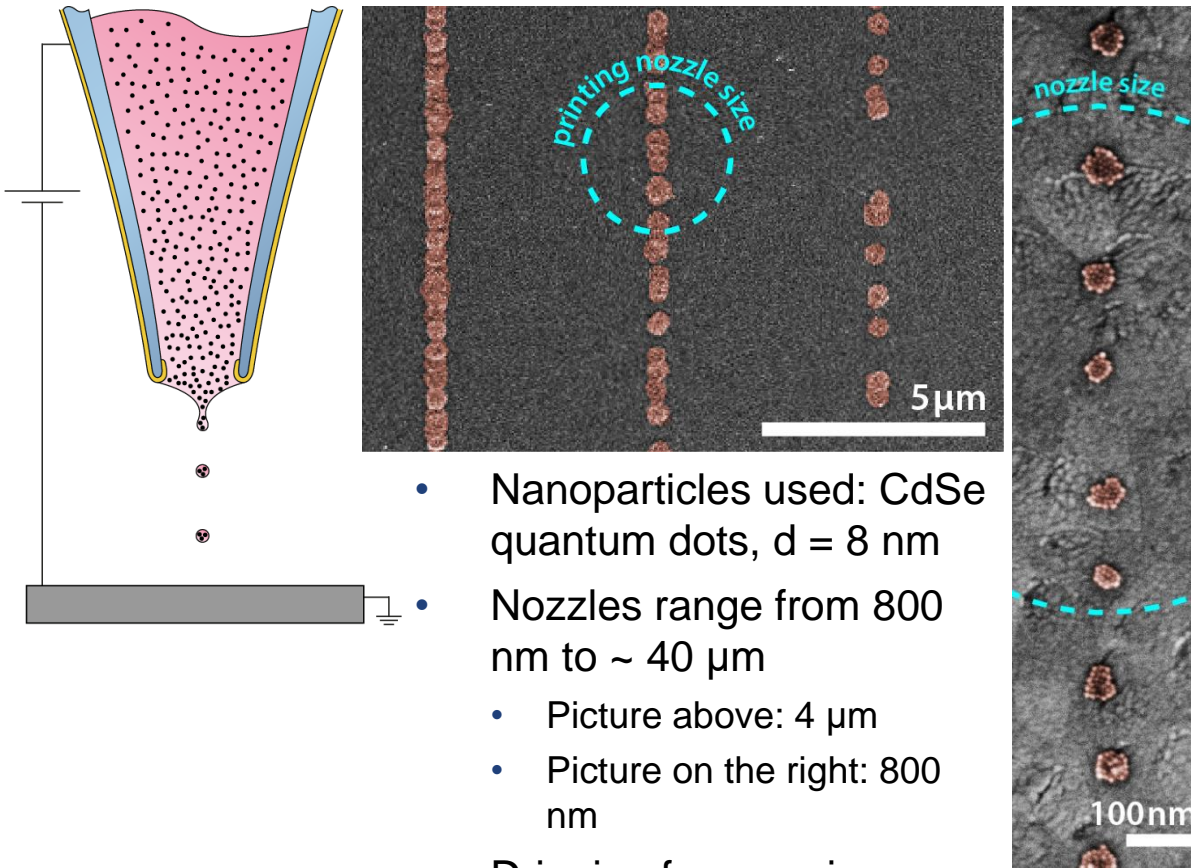
Silicon shards - $d = 0-15 \mu\text{m}$



Linewidth: $92 \mu\text{m} \pm 17 \mu\text{m}$.

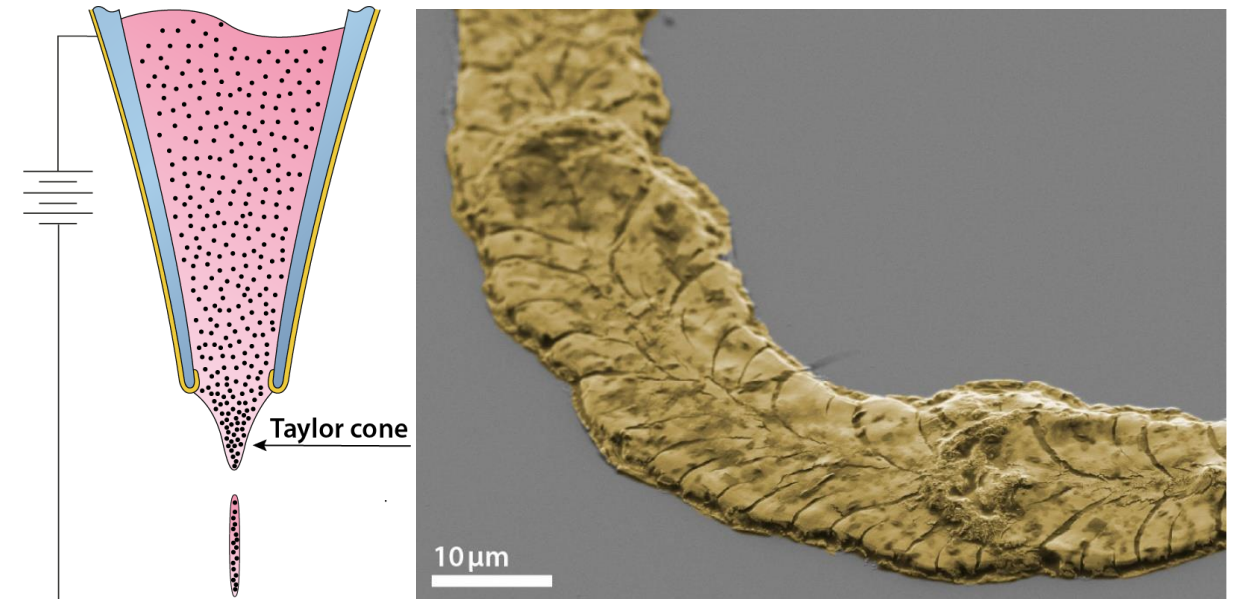
Electrohydrodynamic printing

■ Micro- / nanodripping mode



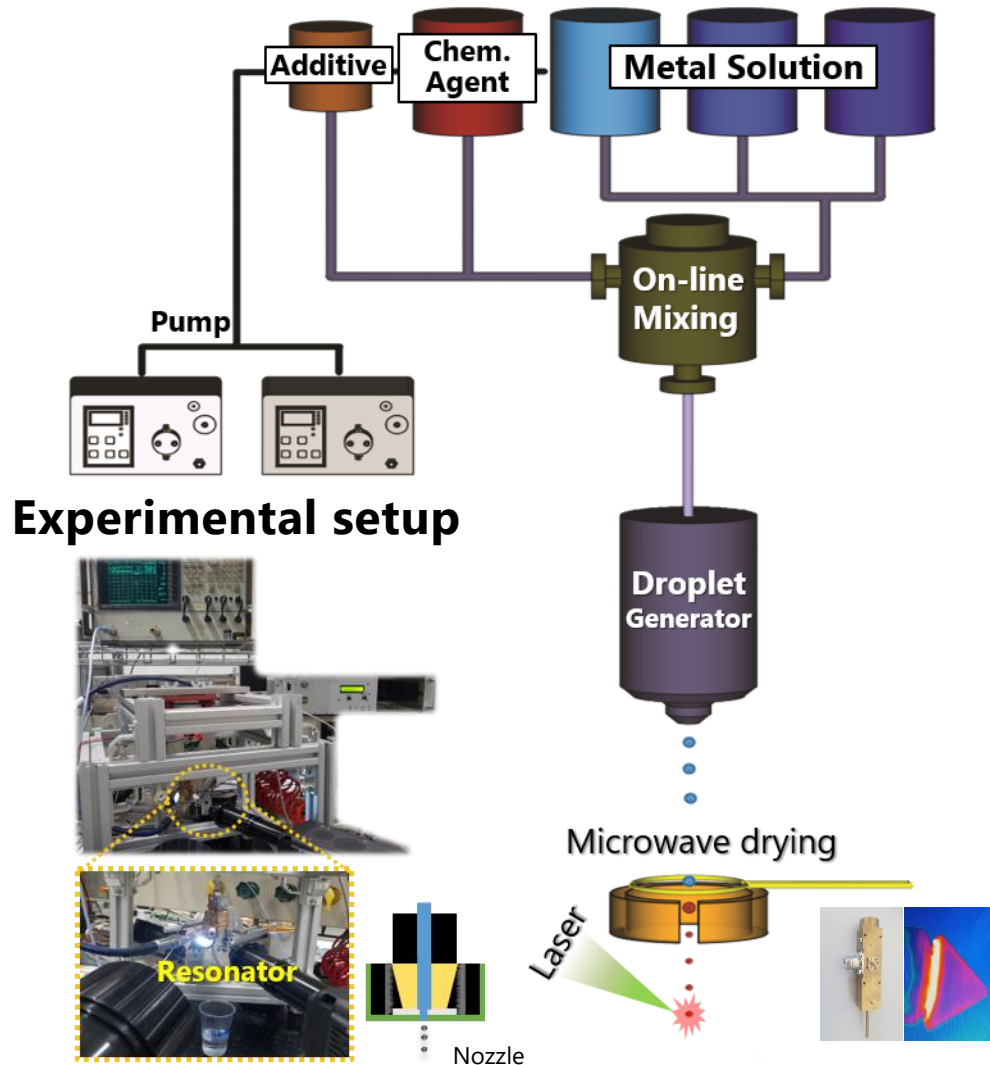
- Nanoparticles used: CdSe quantum dots, $d = 8 \text{ nm}$
- Nozzles range from 800 nm to $\sim 40 \text{ }\mu\text{m}$
 - Picture above: $4 \text{ }\mu\text{m}$
 - Picture on the right: 800 nm
- Dripping frequencies usually below 1 kHz

■ Cone jetting mode

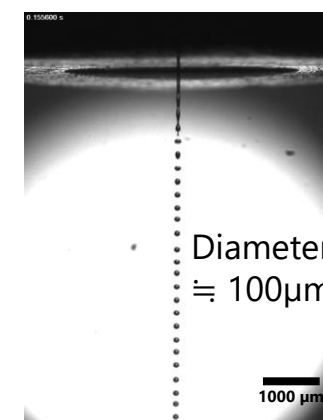


- Nanoparticles used: Gold, 5 nm
- Nozzle diameter: $30 \text{ }\mu\text{m}$
- Stage translation speed: 0.3 mm/s
- Depending on the solvent (e.g. for water), the printing resolution is now limited by the solvent evaporation

High-throughput droplet generation and microwave resonator



High-throughput droplet generation

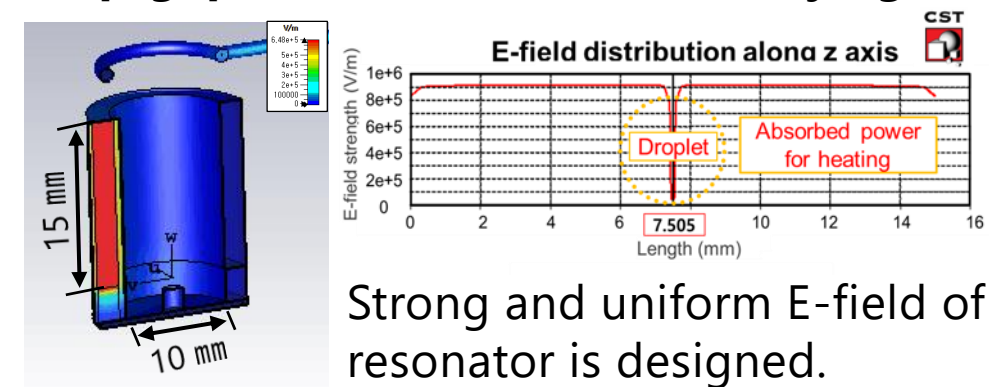


OpenFOAM

| | |
|------------------------------|------------------|
| Material | Water (20°C) |
| Nozzle dia. | 60 μm |
| Flow rate | 0.5 ml/min |
| Frequency | 15 kHz |
| Droplet size Exp. vs. Sim | 3.5% |

High-throughput droplet generation (15kHz) with simulation are validated.

Loop-gap resonator microwave drying



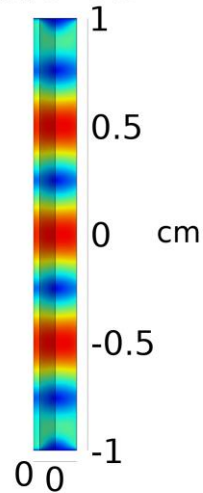
Strong and uniform E-field of resonator is designed.

- Problematic:
 - What is the effect of solid particles on laminar jet destabilization?
 - **Methodology:** Numerical Simulation
- Observations
 - Multistage non-linear modification of the pinch-off dynamics
 - **Outlook:** How to control the output of particulate jet destabilization?

Break up time:

$$t_p = 59ms$$

Time=0 s



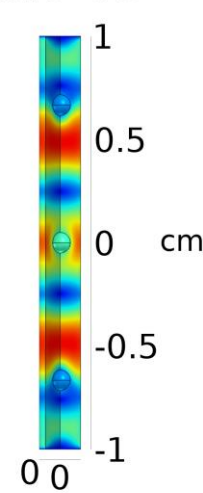
cm

m/s
 $\times 10^{-5}$



$$t_p = 55ms$$

Time=0 s



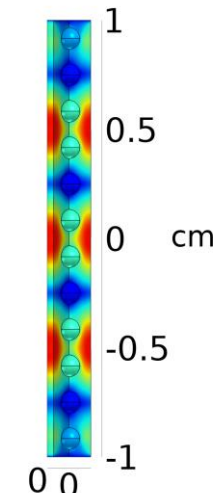
cm

m/s
 $\times 10^{-5}$



$$t_p = 78ms$$

Time=0 s



cm

m/s
 $\times 10^{-6}$



Parameters

$$Oh = \frac{\mu}{\sqrt{\rho\gamma R}} = 10$$

$$R_p = 0.6$$

$$\rho_s/\rho = 10$$

WP5 - Prototype LMD reactor modification



Thank you

Axicone optical system : \varnothing : 20 μm , coaxial powder injection

